

# Progress meeting

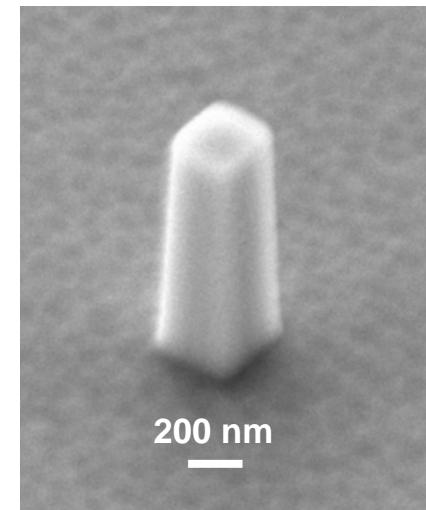
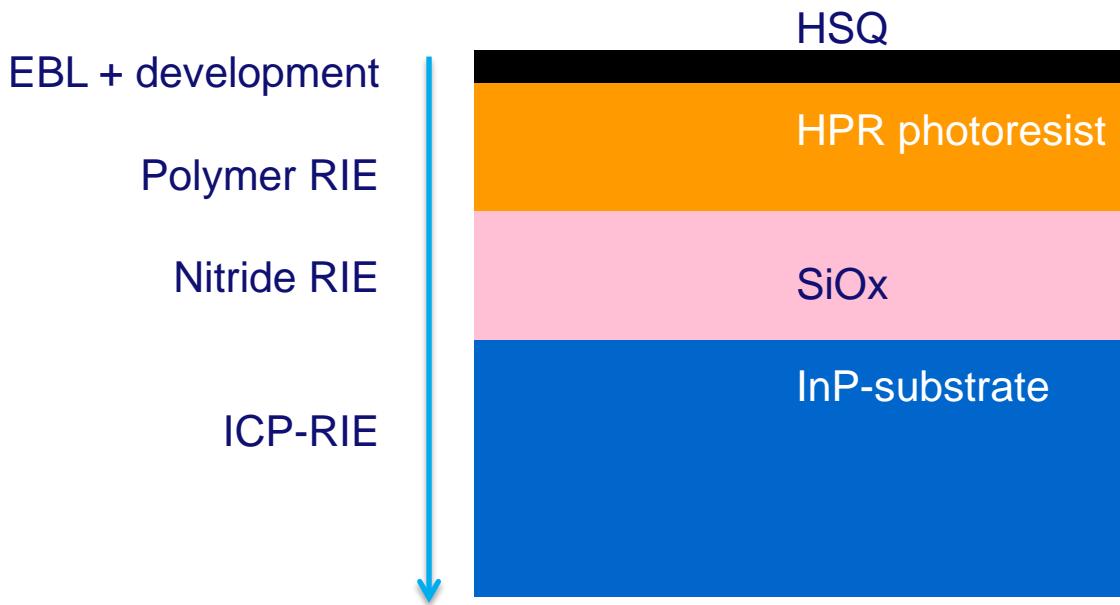
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13/05/2013



# Fabrication

- Nanopillars



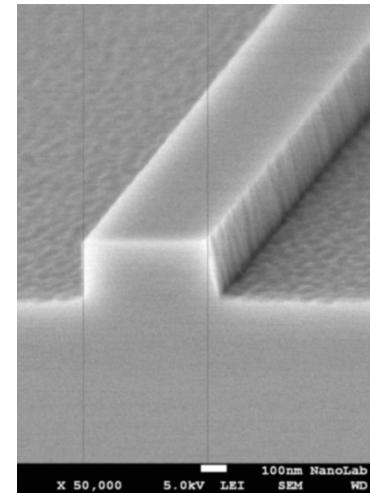
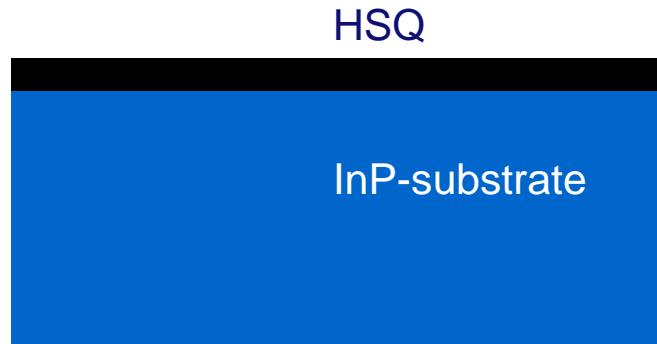
- No sidewall roughness
- High verticality is possible

# Fabrication

- Waveguides

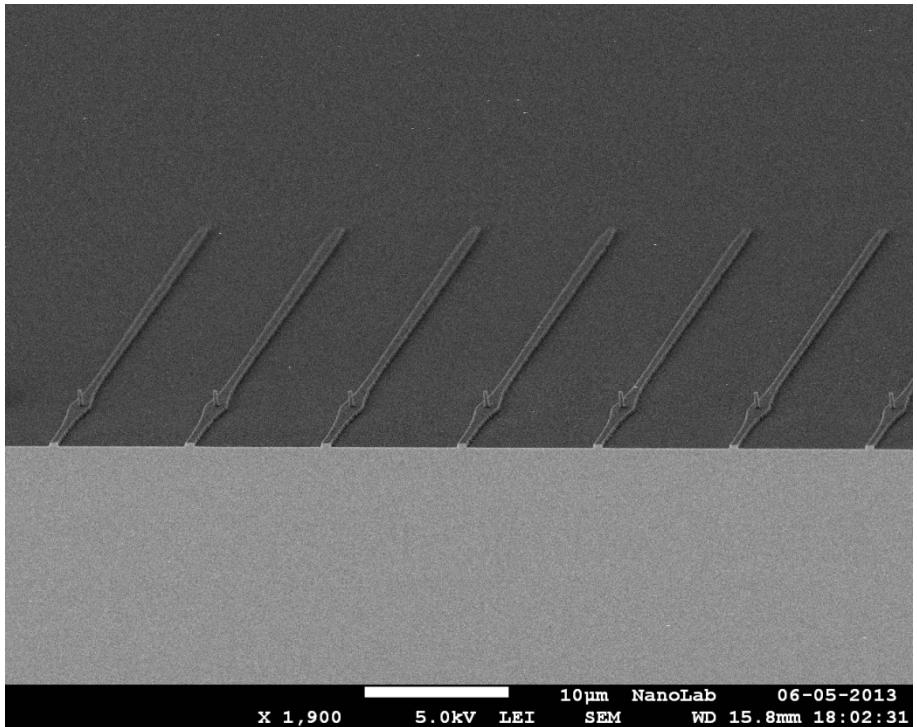
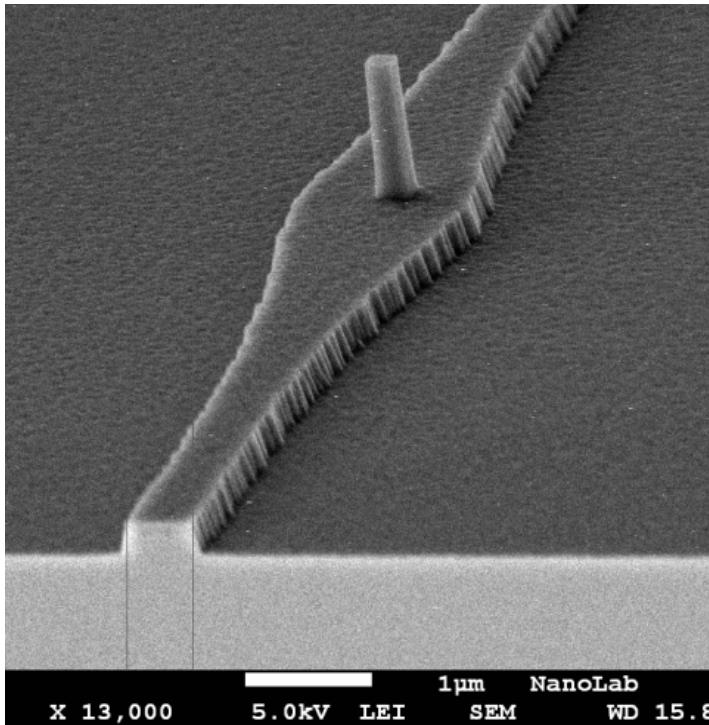
EBL + development

ICP-RIE



- No planarization needed
- No critical roughness

# Pillar on waveguide (first results)

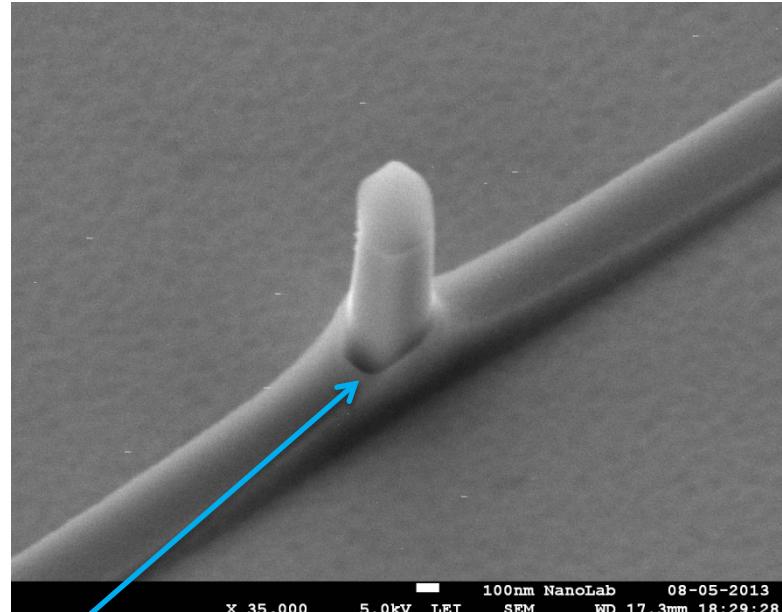
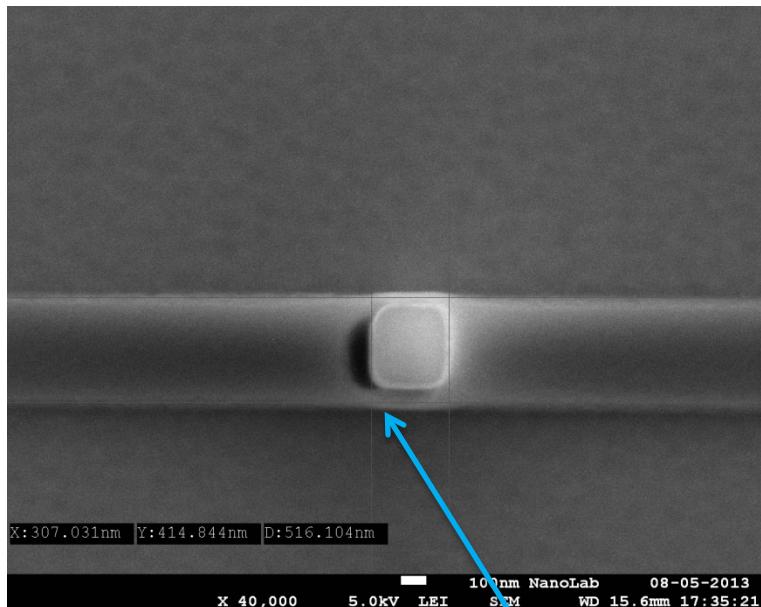


- High roughness
- Bump surrounding pillar

- Lasers array seems feasible from alignment point of view

# Newest results

- Reduced roughness
- No bump surrounding pillar



New problem: Resist holes  
(non-exposed region)



# Other issues

- M13: Initial characterization of unbounded plasmonic lasers
  - New proposed name: Characterization of initial fabrication results of plasmonic/metallic lasers